## ABSTRACT OF THE DISCLOSURE

The present invention relates to a vaporizer for CVD, a solution vaporization type CVD apparatus and a vaporization method for CVD which suppress clogging of a solution pipe or the like and extend continuous operation times. A vaporizer for CVD of the present invention comprises a plurality of raw-material solution pipes which respectively supply a plurality of raw-material solutions separately from one another, a carrier gas pipe disposed in such a manner as to surround the exteriors of the raw-material-solution pipes and allows the pressurized carrier gas to flow to the exterior of each of the plurality of raw material solution pipes, an orifice provided in the leading end of the carrier gas pipe, and spaced away from the leading ends of the raw-material-solution pipes, a vaporization tube connected to the leading end of the carrier gas pipe and led to the interior of the carrier gas pipe via the orifice, and a heater which is heating means for heating the vaporization tube.